

THE COMMISSIONER FOR PATENTS
P.O.Box 1450, Alexandria, VA 22313-1450

13049 U.S.PTO



Sir:

011504

Transmitted herewith for filing is the Patent Application of:

Inventor: VINCENT S. CHANG, CHIA-LIN CHEN, CHI-CHUN CHEN, TZE-LIANG LEE, SHIH-CHANG CHEN, CHIEN-HAO CHEN

For: HIGH TEMPERATURE HYDROGEN ANNEALING OF A GATE INSULATOR LAYER TO INCREASE ETCHING

SELECTIVITY BETWEEN CONDUCTIVE GATE STRUCTURE AND GATE INSULATOR LAYER

Enclosed are:

3 sheets of drawing(s) - formal.

An assignment of the invention to Taiwan Semiconductor Manufacturing Co.

An associate power of attorney Applicant claims small entity status

Request & Certification under 35 USC 122(b)(2)(b)(i)

The filing fee has been calculated as shown below:

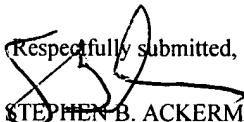
(Col. 1)	(Col. 2)	OTHER THAN A SMALL ENTITY
FOR:	NO. FILED	NO. EXTRA
BASIC FEE		
TOTAL CLAIMS	20 -20=	0
INDEP CLAIMS	3 -3=	0
		SUB TOTAL
		\$ 770.
		ASSIGNMENT
		\$40.
		TOTAL
		\$ 810.

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Any patent application processing fees under 37 CFR §1.17.

Respectfully submitted,

STEPHEN B. ACKERMAN, REG. NO. 37,761

EXPRESS MAIL CERTIFICATE

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I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail in an envelope addressed to Assistant Commissioner of Patents, Alexandria, VA, 22313-1450. Applicant and/or Attorney requests the date of deposit as the Filing Date.

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